

The documentation and process conversion measures necessary to comply with this revision shall be completed by 1 September 2020.

INCH-POUND

MIL-PRF-19500/707C
W/AMENDMENT 1
1 June 2020
SUPERSEDING
MIL-PRF-19500/707C
11 February 2015

PERFORMANCE SPECIFICATION SHEET

TRANSISTOR, FIELD EFFECT RADIATION HARDENED
(TOTAL DOSE AND SINGLE EVENT EFFECTS)
N-CHANNEL, SILICON, TYPES 2N7500U5, 2N7501U5, 2N7502U5, AND 2N7562U5
JANTXVR AND JANSR

This specification is approved for use by all Departments and Agencies of the Department of Defense.

The requirements for acquiring the product described herein shall consist of this specification sheet and [MIL-PRF-19500](#).

1. SCOPE

1.1 Scope. This specification covers the performance requirements for a N-Channel, enhancement-mode, MOSFET, radiation hardened (total dose and single event effects (SEE)), power transistor for use in particular power-switching applications. Two levels of product assurance (JANTXV and JANS) are provided for each encapsulated device type as specified in [MIL-PRF-19500](#), with avalanche energy maximum rating (E_{AS}) and maximum avalanche current (I_{AS}). See 6.5 for unencapsulated JANHC and JANKC die versions.

1.2 Package outlines. The device package outlines are as follows: LCC-18 surface mount in accordance with [figure 1](#) for all encapsulated device types. See 6.5 for unencapsulated devices.

1.3 Maximum ratings. T_A = +25°C, unless otherwise specified.

Type	P _T (1) T _C = +25°C	P _T T _A = +25°C	R _{θJC} (2)	V _{DS}	V _{DG}	V _{GS}	I _{D1} (3) (4) T _C =+25°C	I _{D2} (3) (4) T _C = +100°C	I _{DM} (5)	I _S	T _J and T _{STG}
	W	W	°C/W	V dc	V dc	V dc	A dc	A dc	A (pk)	A dc	°C
2N7500U5	25	1.25	5.0	130	130	±20	9.0	6.0	36.0	9.0	-55
2N7501U5	25	1.25	5.0	200	200	±20	6.3	4.0	25.2	6.3	to
2N7502U5	25	1.25	5.0	250	250	±20	5.0	3.2	20.0	5.0	+150
2N7562U5	25	1.25	5.0	250	250	±20	5.0	3.2	20.0	5.0	

- (1) Derate linearly 0.2 W/°C for T_C > +25°C;
- (2) See [figure 2](#), thermal impedance curves.
- (3) The following formula derives the maximum theoretical I_D limit. I_D is limited by package design.

$$I_D = \sqrt{\frac{T_{JM} - T_C}{(R_{\theta JC}) \times (R_{DS(on)} \text{ at } T_{JM})}}$$

- (4) See [figure 3](#), maximum drain current graph.
- (5) I_{DM} = 4 X I_{D1}, as defined in note (3).

Comments, suggestions, or questions on this document should be addressed to DLA Land and Maritime, ATTN: VAC, P.O. Box 3990, Columbus, OH 43218-3990, or emailed to Semiconductor@dla.mil. Since contact information can change, you may want to verify the currency of this address information using the ASSIST Online database at <https://assist.dla.mil>.



MIL-PRF-19500/707C
W/AMENDMENT 1

1.4 Primary electrical characteristics at T_C = +25°C.

Type	Min V _{(BR)DSS} V _{GS} = 0 I _D = 1.0mA dc	V _{GS(TH)1} V _{DS} ≥ V _{GS} I _D = 1.0 mA dc	Max I _{DSS1} V _{GS} = 0 V _{DS} = 80 percent of rated V _{DS}	Max r _{DS(on)} (1) V _{GS} = 12V, I _D = I _{D2}		E _{AS}
				T _J = +25°C	T _J = +150°C	
	<u>V dc</u>	<u>V dc</u> <u>Min</u> <u>Max</u>	<u>μA dc</u>	<u>Ω</u>	<u>Ω</u>	<u>mJ</u>
2N7500U5	130	2.5 4.5	10	0.130	0.300	87
2N7501U5	200	2.5 4.5	10	0.270	0.621	94
2N7502U5	250	2.5 4.5	10	0.450	0.990	93
2N7562U5	250	2.5 4.5	10	0.450	0.990	93

(1) Pulsed (see 4.5.1).

1.5 Part or Identifying Number (PIN). The PIN is in accordance with MIL-PRF-19500, and as specified herein. See 6.6 for PIN construction example and 6.7 for a list of available PINs.

1.5.1 JAN certification mark and quality level for encapsulated devices. The quality level designators for encapsulated devices that are applicable for this specification sheet from the lowest to the highest level are as follows: "JANTXV" and "JANS".

1.5.2 Radiation hardness assurance (RHA) designator. The RHA levels that are applicable for this specification sheet from lowest to highest for JANTXV and JANS quality levels are as follows: "M", "D", "P", "L", and "R".

1.5.3 Device type. The designation system for the device types of transistors covered by this specification sheet are as follows.

1.5.3.1 First number and first letter symbols. The transistors of this specification sheet use the first number and letter symbols "2N".

1.5.3.2 Second number symbols. The second number symbols for the transistors covered by this specification sheet are as follows: "7500", "7501", "7502" and "7562".

1.5.4 Suffix letters. The suffix letters "U5" are used on devices that are packaged in the LCC-18 surface mount package of figure 1.

* 1.5.5 Lead finish. The lead finishes applicable to this specification sheet are listed on QPDSIS-19500.

MIL-PRF-19500/707C
W/AMENDMENT 1

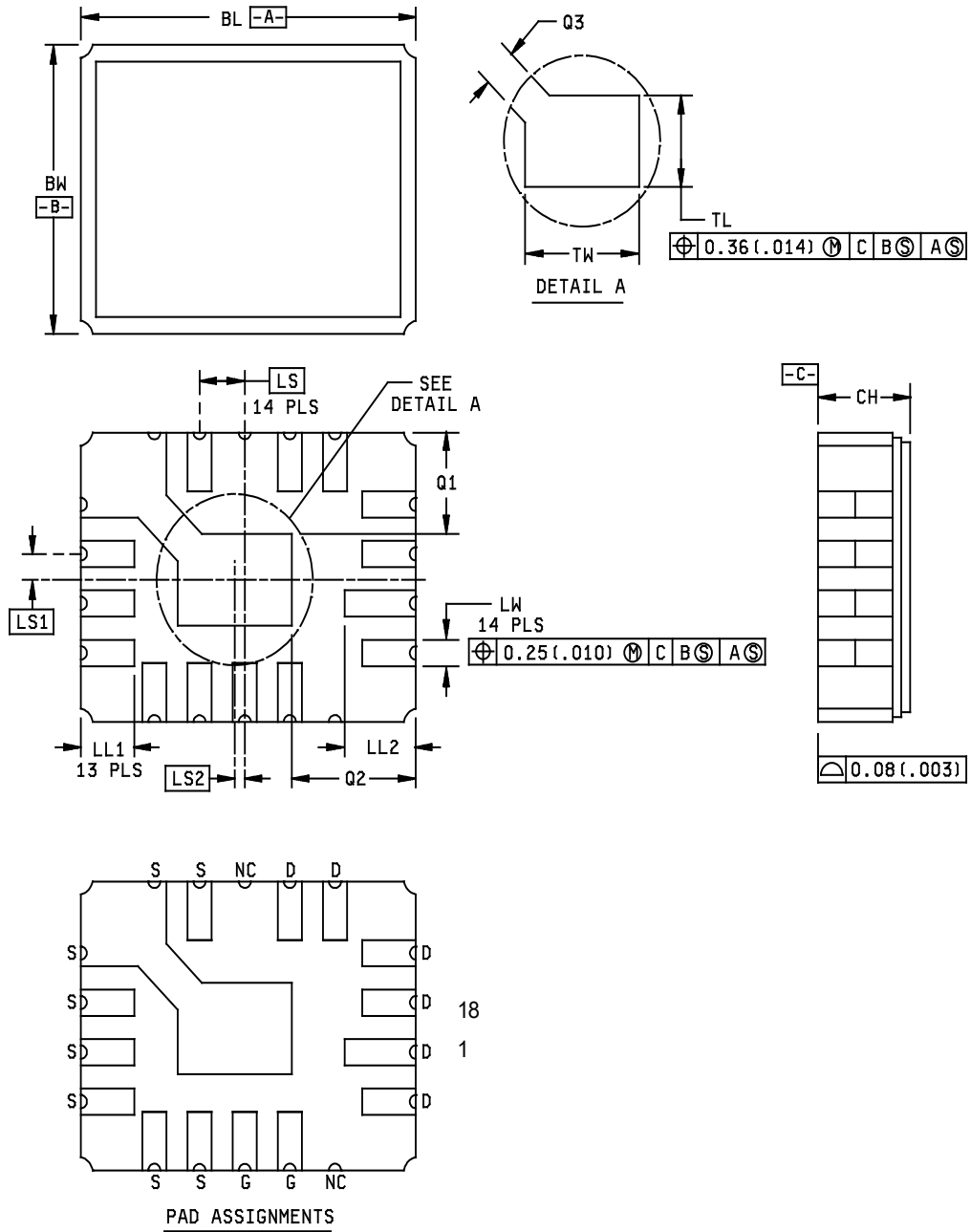


FIGURE 1. Physical dimensions for LCC-18.

MIL-PRF-19500/707C
W/AMENDMENT 1

Symbol	Dimensions			
	Inches		Millimeters	
	Min	Max	Min	Max
BL	.345	.360	8.77	9.14
BW	.280	.295	7.12	7.49
CH	.095	.115	2.42	2.92
LL ₁	.040	.055	1.02	1.39
LL ₂	.055	.065	1.39	1.65
LS	.050 BSC		1.27 BSC	
LS ₁	.025 BSC		.635 BSC	
LS ₂	.008 BSC		.203 BSC	
LW	.020	.030	0.51	0.76
Q ₁	.105 REF		2.67 REF	
Q ₂	.120 REF		3.05 REF	
Q ₃	.045	.055	1.15	1.39
TL	.070	.080	1.78	2.03
TW	.120	.130	3.05	3.30

NOTES:

1. Dimensions are in inches.
2. Millimeters are given for general information only.
3. Dimensions and tolerancing shall be in accordance with ASME Y14.5M.

FIGURE 1. Physical dimensions for LCC-18 - Continued.

MIL-PRF-19500/707C
W/AMENDMENT 1

2. APPLICABLE DOCUMENTS

2.1 General. The documents listed in this section are specified in sections 3 and 4 of this specification. This section does not include documents cited in other sections of this specification or recommended for additional information or as examples. While every effort has been made to ensure the completeness of this list, document users are cautioned that they must meet all specified requirements of documents cited in sections 3 and 4 of this specification, whether or not they are listed.

2.2 Government documents.

2.2.1 Specifications, standards, and handbooks. The following specifications, standards, and handbooks form a part of this document to the extent specified herein. Unless otherwise specified, the issues of these documents are those cited in the solicitation or contract.

DEPARTMENT OF DEFENSE SPECIFICATIONS

[MIL-PRF-19500](#) - Semiconductor Devices, General Specification for.

DEPARTMENT OF DEFENSE STANDARDS

[MIL-STD-750](#) - Test Methods for Semiconductor Devices.

* (Copies of these documents are available online at <https://quicksearch.dla.mil/>.)

2.3 Order of precedence. Unless otherwise noted herein or in the contract, in the event of a conflict between the text of this document and the references cited herein, the text of this document takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

3. REQUIREMENTS

3.1 General. The individual item requirements shall be as specified in [MIL-PRF-19500](#) and as modified herein.

3.2 Qualification. Devices furnished under this specification shall be products that are manufactured by a manufacturer authorized by the qualifying activity for listing on the applicable qualified manufacturers list before contract award (see [4.2](#) and [6.3](#)).

3.3 Abbreviations, symbols, and definitions. Abbreviations, symbols, and definitions used herein shall be as specified in [MIL-PRF-19500](#) and as follows.

I_{AS} Rated avalanche current, nonrepetitive
nC nano Coulomb.

3.4 Interface and physical dimensions. Interface and physical dimensions shall be as specified in [MIL-PRF-19500](#), and on [figure 1](#) (LCC-18) herein.

3.4.1 Lead finish. Lead finish shall be solderable in accordance with [MIL-PRF-19500](#), [MIL-STD-750](#), and herein. Where a choice of lead finish is desired, it shall be specified in the acquisition document (see [6.2](#)).

MIL-PRF-19500/707C
W/AMENDMENT 1

* 3.5 Electrostatic discharge sensitive (ESDS). The devices covered by this specification sheet have been classified as ESDS. The devices shall be handled in accordance with the ESD program established to comply with the requirements of MIL-PRF-19500 to avoid damage due to the accumulation of static charge. The following handling practices shall be followed:

- a. Devices should be handled on benches with conductive handling devices.
- b. Ground test equipment, tools, and personnel handling devices.
- c. Do not handle devices by the leads.
- d. Store devices in conductive foam or carriers.
- e. Avoid use of plastic, rubber or silk in MOS areas.
- f. Maintain relative humidity above 50 percent if practical.
- g. Care should be exercised during test and troubleshooting to apply not more than maximum rated voltage to any lead.
- h. Gate must be terminated to source, $R \leq$ or 100 k Ω , whenever bias voltage is applied drain to source.

3.6 Electrical performance characteristics. Unless otherwise specified herein, the electrical performance characteristics are as specified in 1.3, 1.4, and table I.

3.7 Electrical test requirements. The electrical test requirements shall be as specified in table I.

3.8 Marking. Marking shall be in accordance with MIL-PRF-19500.

3.9 Workmanship. Semiconductor devices shall be processed in such a manner as to be uniform in quality and shall be free from other defects that will affect life, serviceability, or appearance.

4. VERIFICATION

4.1 Classification of inspections. The inspection requirements specified herein are classified as follows:

- a. Qualification inspection (see 4.2).
- b. Screening (see 4.3).
- c. Conformance inspection (see 4.4 and tables I and II).

4.2 Qualification inspection. Qualification inspection shall be in accordance with MIL-PRF-19500 and as specified herein.

4.2.1 Group E qualification. Group E inspection shall be performed for qualification or re-qualification only. In case qualification was awarded to a prior revision of the specification sheet that did not request the performance of table III tests, the tests specified in table III herein that were not performed in the prior revision shall be performed on the first inspection lot of this revision to maintain qualification.

4.2.1.1 Single event effects (SEE). SEE shall be performed at initial qualification and after process or design changes which may affect radiation hardness (see table III and table IV). Upon qualification, manufacturers shall provide the verification test conditions from section 5 of method 1080 of MIL-STD-750 that were used to qualify the device for inclusion into section 6 of the slash sheet. End-point measurements shall be in accordance with table II. SEE characterization data shall be made available upon request of the qualifying or acquiring activity.

MIL-PRF-19500/707C
W/AMENDMENT 1

4.3 Screening (JANS, JANTX, and JANTXV). Screening shall be in accordance with table E-IV of MIL-PRF-19500, and as specified herein. The following measurements shall be made in accordance with table I herein. Devices that exceed the limits of table I herein shall not be acceptable.

Screen (1) (2)	Measurement	
	JANS	JANTXV
(3)	Gate stress test (see 4.3.1)	Gate stress test (see 4.3.1)
(3)	Method 3470 of MIL-STD-750, E _{AS} test (see 4.3.2)	Method 3470 of MIL-STD-750, E _{AS} test (see 4.3.2)
(3) 3c	Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3)	Method 3161 of MIL-STD-750, thermal impedance (see 4.3.3)
9	Subgroup 2 of table I herein I _{GSSF1} , I _{GSSR1} , and I _{DSS1} as a minimum	Not applicable
10	Method 1042 of MIL-STD-750, test condition B	Method 1042 of MIL-STD-750, test condition B
11	I _{GSSF1} , I _{GSSR1} , I _{DSS1} , r _{DS(ON)1} , V _{GS(TH)1} , subgroup 2 of table I herein. ΔI _{GSSF1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{GSSR1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{DSS1} = ±10 μA dc or ±100 percent of initial value, whichever is greater.	I _{GSSF1} , I _{GSSR1} , I _{DSS1} , r _{DS(ON)1} , V _{GS(TH)1} , subgroup 2 of table I herein.
12	Method 1042 of MIL-STD-750, test condition A	Method 1042 of MIL-STD-750, test condition A
13	Subgroups 2 and 3 of table I herein ΔI _{GSSF1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{GSSR1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{DSS1} = ±10 μA dc or ±100 percent of initial value, whichever is greater. Δr _{DS(ON)1} = ±20 percent of initial value. ΔV _{GS(TH)1} = ±20 percent of initial value.	Subgroup 2 of table I herein ΔI _{GSSF1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{GSSR1} = ±20 nA dc or ±100 percent of initial value, whichever is greater. ΔI _{DSS1} = ±10 μA dc or ±100 percent of initial value, whichever is greater. Δr _{DS(ON)1} = ±20 percent of initial value. ΔV _{GS(TH)1} = ±20 percent of initial value.

- (1) At the end of the test program, I_{GSSF1}, I_{GSSR1}, and I_{DSS1} are measured.
- (2) An out-of-family program to characterize I_{GSSF1}, I_{GSSR1}, I_{DSS1}, and V_{GS(TH)1} shall be invoked.
- (3) Shall be performed anytime after temperature cycling, screen 3a; JANTXV level does not need to be repeated in screening requirements.

MIL-PRF-19500/707C
W/AMENDMENT 1

4.3.1 Gate stress test. Apply $V_{GS} = 24$ V minimum for $t = 250$ μ s minimum.

4.3.2 Single pulse avalanche energy (E_{AS}).

- a. Peak current, $I_{AS} = I_{D1}$.
- b. Inductance, $L = (2 * E_{AS} / (I_{D1})^2) * ((V_{BR} - V_{DD}) / V_{BR})$ mH minimum.
- c. Gate to source resistor, $R_{GS}: 25 \Omega \leq R_{GS} \leq 200 \Omega$.
- d. Supply voltage, $V_{DD} = 25$ V dc, except $V_{DD} = 50$ V dc for 2N7502U5, 2N7562U5.
- e. Initial case temperature, $T_C = +25^\circ$ C, -5° C, $+10^\circ$ C.
- f. Gate voltage, $V_{GS} = 12$ V dc.
- g. Number of pulses to be applied: 1 pulse minimum.

* 4.3.3 Thermal impedance. The thermal impedance measurements shall be performed in accordance with method 3161 of [MIL-STD-750](#) using the guidelines in that method for determining I_M , I_H , t_H , t_{MD} , t_{sw} , (and V_H where appropriate). See [table III](#), group E, subgroup 4 herein.

4.4 Conformance inspection. Conformance inspection shall be in accordance with [MIL-PRF-19500](#).

4.4.1 Group A inspection. Group A inspection shall be conducted in accordance with table E-V of [MIL-PRF-19500](#) and [table I](#) herein.

4.4.2 Group B inspection. Group B inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VIA (JANS) and table E-VIB (JANTXV) of [MIL-PRF-19500](#), and as follows.

4.4.2.1 Group B inspection, table E-VIA (JANS) of [MIL-PRF-19500](#).

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B3	1051	Test condition G, 100 cycles.
B3	2077	Scanning electron microscope (SEM).
B4	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.
B5	1042	Accelerated steady-state gate bias, condition B, $V_{GS} =$ rated; $T_A = +175^\circ$ C, $t = 24$ hours minimum; or $T_A = +150^\circ$ C, $t = 48$ hours minimum.
B5	1042	Accelerated steady-state reverse bias, condition A, $V_{DS} =$ rated; $T_A = +175^\circ$ C, $t = 120$ hours minimum; or $T_A = +150^\circ$ C, $t = 240$ hours minimum.

MIL-PRF-19500/707C
W/AMENDMENT 1

4.4.2.2 Group B inspection, table E-VIB (JANTXV) of MIL-PRF-19500.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
B2	1051	Test condition G, 25 cycles.
B3	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.

4.4.3 Group C inspection. Group C inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-VII of MIL-PRF-19500 and as follows.

<u>Subgroup</u>	<u>Method</u>	<u>Condition</u>
C2	2036	Terminal strength is not applicable.
C5	3161	See 4.3.3, $R_{\theta JC} = 5.0$ °C/W.
C6	1042	Intermittent operation life, condition D. No heat sink or forced-air cooling on the device shall be permitted during the on cycle. $t_{on} = 30$ seconds minimum.

4.4.4 Group D inspection. Group D inspection shall be conducted in accordance with table E-VIII of MIL-PRF-19500 and table II herein.

4.4.5 Group E inspection. Group E inspection shall be conducted in accordance with the conditions specified for subgroup testing in table E-IX of MIL-PRF-19500 and as specified in table III herein. Electrical measurements (end-points) shall be in accordance with table I, subgroup 2 herein.

4.4.5.1 SEE. Design capability shall be tested on the initial qualification and thereafter whenever a major die design or process change is introduced. See the design safe operating area figures herein. End-point measurements shall be in accordance with table III.

4.5 Methods of inspection. Methods of inspection shall be as specified in the appropriate tables and as follows.

4.5.1 Pulse measurements. Conditions for pulse measurement shall be as specified in section 4 of MIL-STD-750.

MIL-PRF-19500/707C
W/AMENDMENT 1
TABLE I. Group A inspection.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Unit
	Method	Condition		Min	Max	
<u>Subgroup 1</u>						
Visual and mechanical inspection	2071					
<u>Subgroup 2</u>						
Thermal impedance <u>2/</u>	3161	See 4.3.3	$Z_{\theta JC}$			$^{\circ}C/W$
Breakdown voltage drain to source	3407	$V_{GS} = 0V$, $I_D = 1$ mA dc, bias condition C	$V_{(BR)DSS}$			
2N7500U5				130		V dc
2N7501U5				200		V dc
2N7502U5				250		V dc
2N7562U5				250		V dc
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}$, $I_D = 1$ mA dc	$V_{GS(TH)1}$	2.5	4.5	V dc
Gate current	3411	$V_{GS} = +20V$ dc, bias condition C, $V_{DS} = 0V$	I_{GSSF1}		+100	nA dc
Gate current	3411	$V_{GS} = -20V$ dc, bias condition C, $V_{DS} = 0V$	I_{GSSR1}		-100	nA dc
Drain current	3413	$V_{GS} = 0V$ dc, bias condition C, $V_{DS} = 80$ percent of rated V_{DS} ,	I_{DSS1}		10	μA dc
Static drain to source on-state resistance	3421	$V_{GS} = 12V$ dc, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)1}$			
2N7500U5					0.130	Ω
2N7501U5					0.270	Ω
2N7502U5					0.450	Ω
2N7562U5					0.450	Ω
Forward voltage	4011	$V_{GS} = 0V$ dc, condition A, pulsed (see 4.5.1), $I_D = I_{D1}$	V_{SD}		1.5	V dc

See footnotes at end of table.

MIL-PRF-19500/707C
W/AMENDMENT 1

TABLE I. Group A inspection - Continued.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Unit
	Method	Condition		Min	Max	
<u>Subgroup 3</u>						
High temperature operation						
$T_C = T_J = +125^\circ\text{C}$						
Gate current	3411	$V_{GS} = \pm 20\text{V dc}$, bias condition C, $V_{DS} = 0\text{V}$	I_{GSS2}		± 200	nA dc
Drain current	3413	$V_{GS} = 0\text{V dc}$, bias condition C, $V_{DS} = 80$ percent of rated V_{DS}	I_{DSS2}		25	$\mu\text{A dc}$
Static drain to source on-state resistance	3421	$V_{GS} = 12\text{V dc}$, condition A, pulsed (see 4.5.1), $I_D = I_{D2}$	$r_{DS(ON)3}$			
2N7500U5					0.247	Ω
2N7501U5					0.540	Ω
2N7502U5					0.945	Ω
2N7562U5					0.945	Ω
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}$, $I_D = 1\text{ mA dc}$	$V_{GS(TH)2}$	1.5		V dc
Low temperature operation						
$T_C = T_J = -55^\circ\text{C}$						
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS(TH)3}$, $I_D = 1\text{ mA dc}$	$V_{GS(TH)3}$		5.5	V dc
<u>Subgroup 4</u>						
Forward transconductance	3475	$I_D = I_{D2}$, $V_{DD} = 15\text{ V dc}$ (see 4.5.1)	g_{FS}			
2N7500U5				5.0		S
2N7501U5				4.2		S
2N7502U5				4.0		S
2N7562U5				4.0		S
Switching time test	3472	$I_D = I_{D2}$, $V_{GS} = 12\text{ V dc}$, $R_G = 7.5\ \Omega$, $V_{DD} = 50$ percent of rated V_{DS}				
Turn-on delay time			$t_{D(on)}$		25	ns
Rise time			t_r		100	ns
Turn-off delay time			$t_{D(off)}$		35	ns
Fall time			t_f		40	ns
<u>Subgroup 5</u>						
Safe operating area test (high voltage)	3474	See figure 4, $t_p = 10\text{ ms min.}$ $V_{DS} = 80$ percent of max. rated V_{DS}				
Electrical measurements		See table I, subgroup 2				

See footnotes at end of table.

MIL-PRF-19500/707C
W/AMENDMENT 1

TABLE I. Group A inspection - Continued.

Inspection <u>1/</u>	MIL-STD-750		Symbol	Limits		Unit				
	Method	Condition		Min	Max					
<u>Subgroup 5</u>										
Safe operating area test (high voltage)	3474	See figure 4, $t_p = 10$ ms min. $V_{DS} = 80$ percent of max. rated V_{DS} See table I, subgroup 2								
Electrical measurements										
<u>Subgroup 6</u>										
Not applicable										
<u>Subgroup 7</u>										
Gate charge	3471	Condition B, $I_D = I_{D1}$, $V_{GS} = 12$ V dc $V_{DD} = 50$ percent of rated V_{DS}	$Q_{G(ON)}$							
On-state gate charge										
2N7500U5							48	nC		
2N7501U5							47	nC		
2N7502U5			28	nC						
2N7562U5			32	nC						
Gate to source charge			Q_{GS}							
2N7500U5									16	nC
2N7501U5									12	nC
2N7502U5									7.4	nC
2N7562U5			11	nC						
Gate to drain charge			Q_{GD}							
2N7500U5									18	nC
2N7501U5									16	nC
2N7502U5									12	nC
2N7562U5			16	nC						
* Reverse recovery time	3473	Condition A, $di/dt = -100$ A/ μ s, $V_{DD} \leq 50$ V, $I_D = I_{D1}$	t_{rr}							
2N7500U5							250	ns		
2N7501U5							274	ns		
2N7502U5							287	ns		
2N7562U5							287	ns		

1/ For sampling plan, see MIL-PRF-19500.

2/ For end-point measurements, this test is required for the following subgroups:

Group B, subgroups 2 and 3 (JANTX/JANTXV).

Group B, subgroups 3 and 4 (JANS).

Group C, subgroup 6.

Group E, subgroup 1.

MIL-PRF-19500/707C
W/AMENDMENT 1
TABLE II. Group D inspection.

Inspection 1/ 2/ 3/	MIL-STD-750		Symbol	Pre-irradiation limits		Post-irradiation limits		Unit
	Method	Conditions		R		R		
				Min	Max	Min	Max	
<u>Subgroup 1</u>								
Not applicable								
<u>Subgroup 2</u>		$T_C = + 25^\circ\text{C}$						
Steady-state total dose irradiation (V_{GS} bias) 4/	1019	$V_{GS} = 12\text{ V}; V_{DS} = 0\text{ V}$						
Steady-state total dose irradiation (V_{DS} bias) 4/	1019	$V_{GS} = 0\text{ V}; V_{DS} = 80$ percent of rated V_{DS} (pre-irradiation)						
End-point electricals								
Breakdown voltage, drain to source	3407	$V_{GS} = 0\text{ V}; I_D = 1\text{ mA};$ bias condition C	$V_{(BR)DSS}$					
2N7500U5				130		130		V dc
2N7501U5				200		200		V dc
2N7502U5				250		250		V dc
2N7562U5				250		250		V dc
Gate to source voltage (threshold)	3403	$V_{DS} \geq V_{GS}; I_D = 1\text{ mA}$	$V_{GS(th)1}$	2.5	4.5	2.0	4.5	V dc
Gate current	3411	$V_{GS} = +20\text{ V}; V_{DS} = 0\text{ V};$ bias condition C	I_{GSSF1}		100		100	nA dc
Gate current	3411	$V_{GS} = -20\text{ V}; V_{DS} = 0\text{ V};$ bias condition C	I_{GSSR1}		-100		-100	nA dc
Drain current	3413	$V_{GS} = 0\text{ V}; V_{DS} = 80$ percent of rated V_{DS} (pre-irradiation); bias condition C	I_{DSS}		10		10	μA dc
Static drain to source on-state voltage	3405	$V_{GS} = 12\text{ V}; I_D = I_{D2};$ condition A, pulsed (see 4.5.1)	$V_{DS(on)}$					
2N7500U5					0.492		0.492	V dc
2N7501U5					0.888		0.888	V dc
2N7502U5					1.286		1.286	V dc
2N7562U5					1.286		1.286	V dc
Forward voltage source drain diode	4011	$V_{GS} = 0\text{ V}; I_D = I_{D1};$ bias condition C	V_{SD}		1.5		1.5	V dc

1/ For sampling plan see MIL-PRF-19500.

2/ Group D qualification may be performed prior to lot formation. Wafers qualified to these group D QCI requirements may be used for any other performance specification utilizing the same die design.

3/ At the manufacturer's option, group D samples need not be subjected to the screening tests, and may be assembled in its qualified package or in any qualified package that the manufacturer has data to correlate the performance to the designated package.

4/ Separate samples shall be pulled for each bias.

MIL-PRF-19500/707C
W/AMENDMENT 1

TABLE III. Group E inspection (all quality levels) - for qualification only.

Inspection	MIL-STD-750		Sample plan
	Method	Conditions	
<u>Subgroup 1</u>			45 devices c = 0
Temperature cycling	1051	Test condition G, 500 cycles	
Hermetic seal	1071	As applicable	
Fine leak			
Gross leak			
Electrical measurements		See table I , subgroup 2	
<u>Subgroup 2</u> ^{1/}			45 devices c = 0
Steady-state gate bias	1042	Test condition B; 1,000 hours	
Electrical measurements		See table I , subgroup 2	
Steady-state reverse bias	1042	Test condition A; 1,000 hours	
Electrical measurements		See table I , subgroup 2	
<u>Subgroup 4</u>			Sample plan N/A
Thermal resistance		See MIL-PRF-19500	
<u>Subgroup 5</u>			3 devices, c = 0
Barometric pressure	1001	Test condition C, see 1.3	
2N7501U5, 2N7502U5 , 2N7562U5 only			
<u>Subgroup 10</u>			22 devices c = 0
Commutating diode for safe operating area test procedure for measuring dv/dt during reverse recovery of power MOSFET transistors or insulated gate bipolar transistors	3476	Test conditions shall be derived by the manufacturer	
<u>Subgroup 11</u>			
SEE ^{2/} ^{3/}	1080	See method 1080 of MIL-STD-750 .	3 devices

^{1/} A separate sample for each test shall be pulled.

^{2/} Group E qualification of SEE testing may be performed prior to lot formation. Qualification may be extended to other performance specifications utilizing the same structurally identical die design.

^{3/} Device qualification to a higher level LET is sufficient to qualify all lower level LETs.

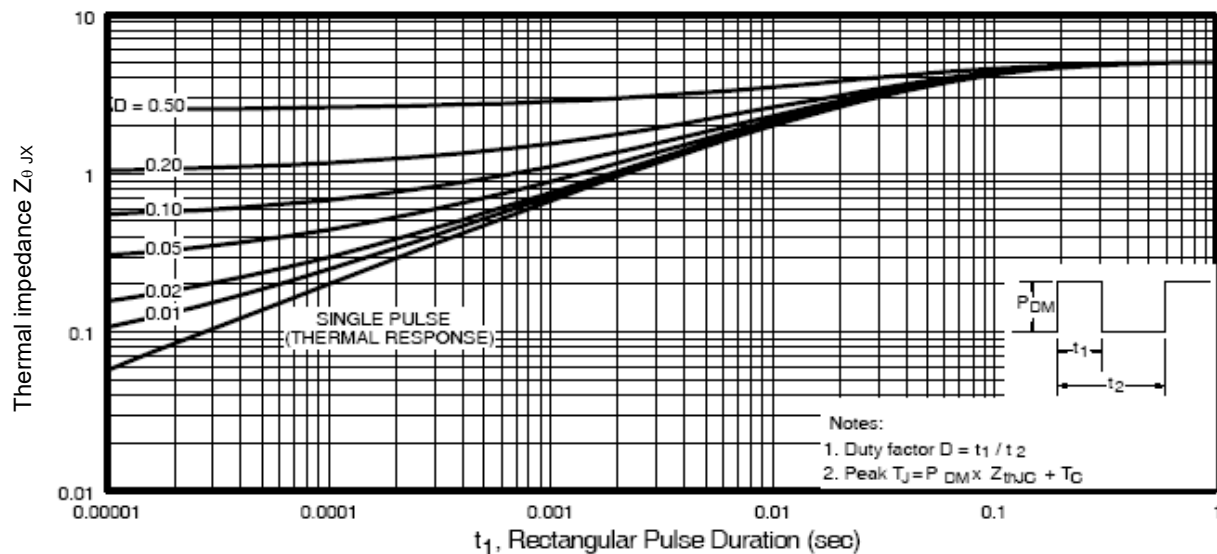
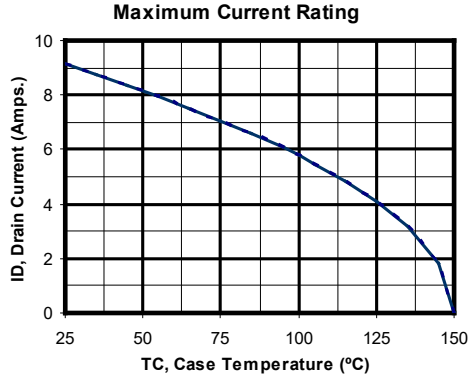


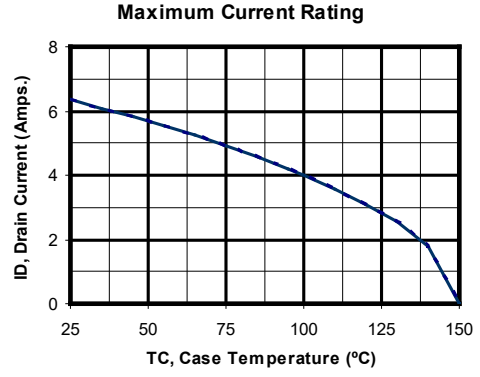
FIGURE 2. Thermal impedance curve.

MIL-PRF-19500/707C
W/AMENDMENT 1

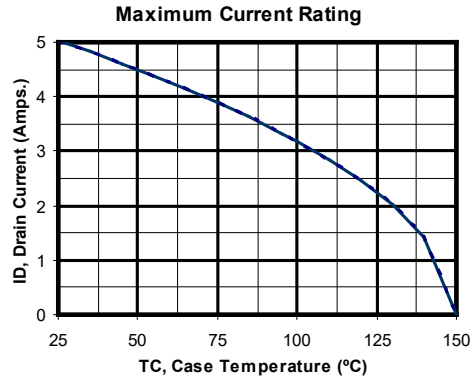
2N7500U5



2N7501U5



2N7502U5, 2N7562U5



* FIGURE 3. Maximum drain current versus case temperature graphs.

2N7500U5

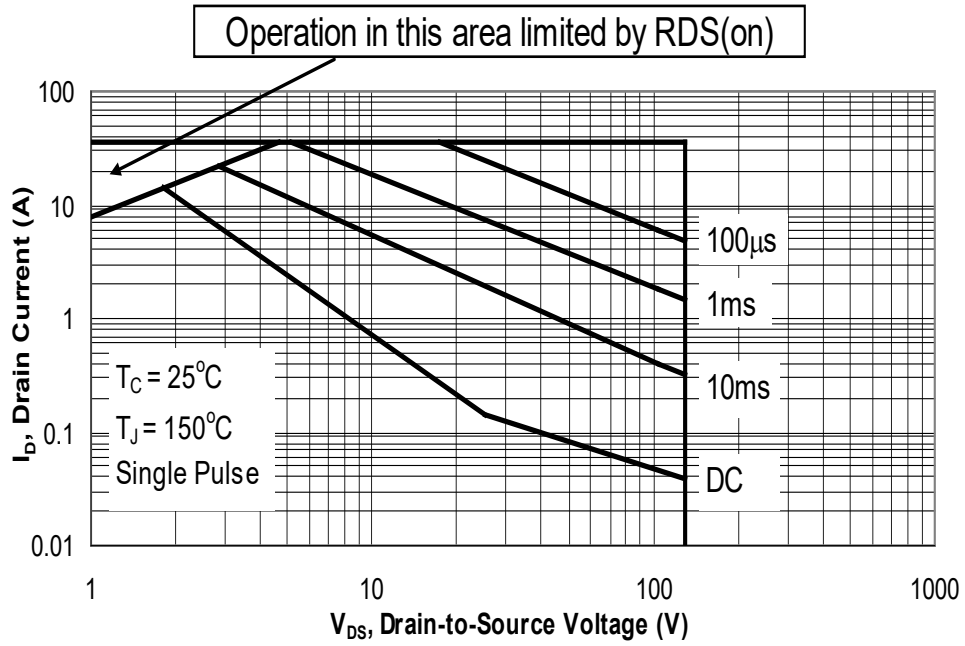


FIGURE 4. Safe operating area graph.

MIL-PRF-19500/707C
W/AMENDMENT 1

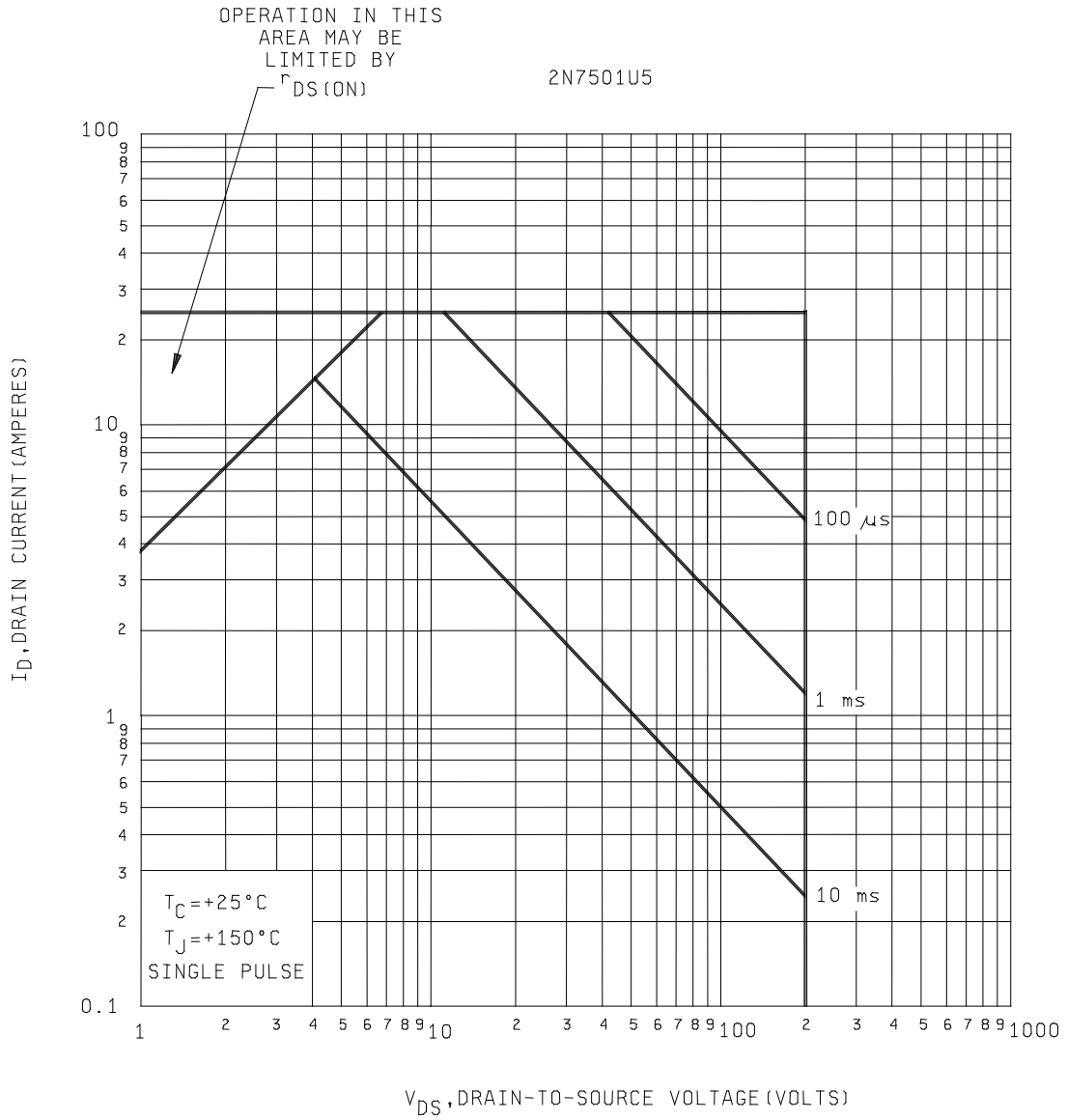
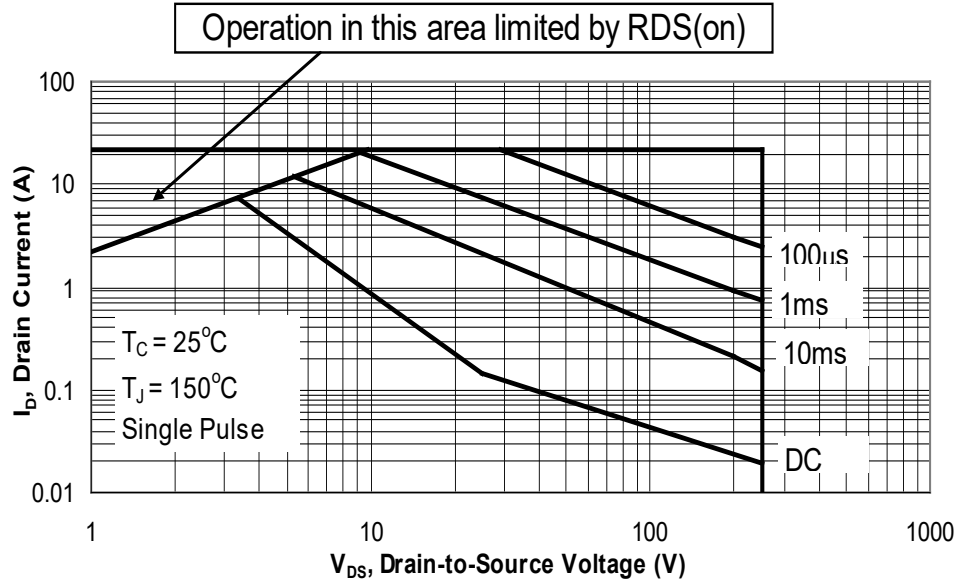


FIGURE 4. Safe operating area graph - Continued.

MIL-PRF-19500/707C
W/AMENDMENT 1

2N7502U5



2N7562U5

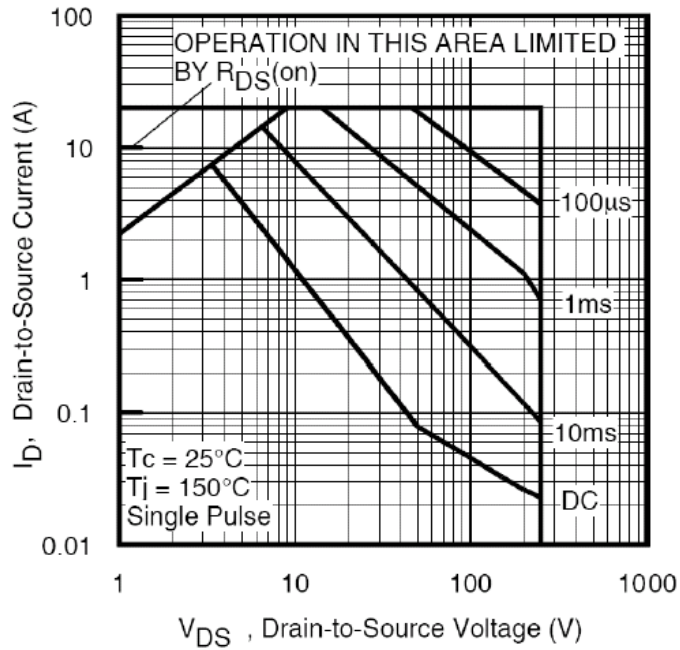


FIGURE 4. Safe operating area graph - Continued.

MIL-PRF-19500/707C
W/AMENDMENT 1

5. PACKAGING

5.1 Packaging. For acquisition purposes, the packaging requirements shall be as specified in the contract or order (see 6.2). When packaging of materiel is to be performed by DoD or in-house contractor personnel, these personnel need to contact the responsible packaging activity to ascertain packaging requirements. Packaging requirements are maintained by the Inventory Control Point's packaging activities within the Military Service or Defense Agency, or within the Military Service's system commands. Packaging data retrieval is available from the managing Military Department's or Defense Agency's automated packaging files, CD-ROM products, or by contacting the responsible packaging activity.

6. NOTES

(This section contains information of a general or explanatory nature that may be helpful, but is not mandatory. The notes specified in MIL-PRF-19500 are applicable to this specification.)

6.1 Intended use. Semiconductors conforming to this specification are intended for original equipment design applications and logistic support of existing equipment.

6.2 Acquisition requirements. Acquisition documents should specify the following:

- a. Title, number, and date of this specification.
- b. Packaging requirements (see 5.1).
- c. Lead finish (see 3.4.1).
- d. The complete Part or Identifying Number (PIN), see 1.5 and 6.6.
- e. For acquisition of RHA designated devices, table II, subgroup 1 testing of group D herein is optional. If subgroup 1 is desired, it should be specified in the contract.
- * f. If SEE testing data is desired, it should be specified in the contract or order (4.2.1.1).
- g. If specific SEE characterization conditions are desired (see section 6.8 and table IV), manufacturer's CAGE code should be specified in the contract or order.

6.3 Qualification. With respect to products requiring qualification, awards will be made only for products which are, at the time of award of contract, qualified for inclusion in Qualified Manufacturers List (QML 19500) whether or not such products have actually been so listed by that date. The attention of the contractors is called to these requirements, and manufacturers are urged to arrange to have the products that they propose to offer to the Federal Government tested for qualification in order that they may be eligible to be awarded contracts or orders for the products covered by this specification. Information pertaining to qualification of products may be obtained from DLA Land and Maritime, ATTN: VQE, P.O. Box 3990, Columbus, OH 43218-3990 or e-mail vqe.chief@dla.mil. An online listing of products qualified to this specification may be found in the Qualified Products Database (QPD) at <https://assist.dla.mil>.

MIL-PRF-19500/707C
W/AMENDMENT 1

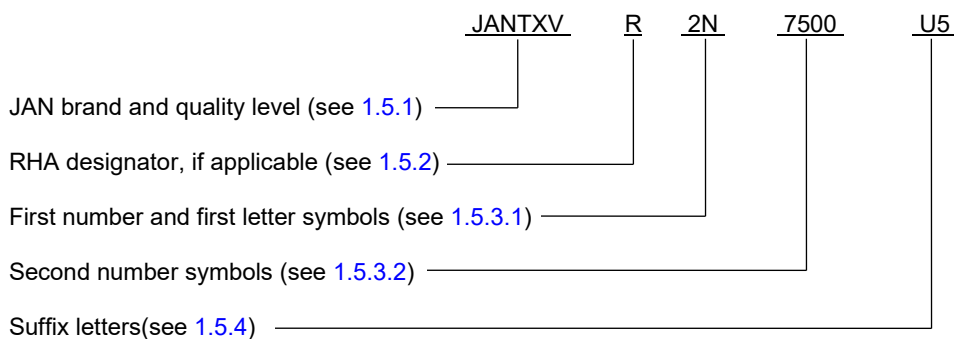
6.4 Cross-reference list. The following table shows the generic P/N and its associated military P/N (without JAN and RHA prefix).

Generic P/N	Military P/N
IRHE57133SE	2N7500U5
IRHE57230SE	2N7501U5
IRHE57234SE	2N7502U5 2N7562U5

6.5 JANC die versions. The JANHC and JANKC die versions of these devices are covered under specification sheet [MIL-PRF-19500/741](#).

6.6 PIN construction example.

6.6.1 Encapsulated devices The PINs for encapsulated devices are constructed using the following form.



6.7 List of PINs. The following is a list of possible PINs available on this specification sheet.

PINs for devices of the "TXV" quality level	PINs for devices of the "TXV" quality level with RHA (1)	PINs for devices of the "S" quality level	PINs for devices of the "S" quality level with RHA (1)
JANTXV2N7500U5	JANTXV#2N7500U5	JANS2N7500U5	JANS#2N7500U5
JANTXV2N7501U5	JANTXV#2N7501U5	JANS2N7501U5	JANS#2N7501U5
JANTXV2N7502U5	JANTXV#2N7502U5	JANS2N7502U5	JANS#2N7502U5
JANTXV2N7562U5	JANTXV#2N7562U5	JANS2N7562U5	JANS#2N7562U5

(1) The number sign (#) represent one of five RHA designators available (M, D, P, L, or R).

6.8 Application data.

6.8.1 Manufacturer specific irradiation data. Each manufacturer qualified to this slash sheet has characterized its devices to the requirements of [MIL-STD-750](#) method 1080 and as specified herein. Since each manufacturer's characterization conditions can be different and can vary by the version of method 1080 qualified to, the [MIL-STD-750](#) method 1080 revision version date and conditions used by each manufacturer for characterization have been listed here (see [table IV](#)) for information only. SEE conditions and figures listed in section 6 are current as of the date of this specification sheet, please contact the manufacturer for the most recent conditions.

MIL-PRF-19500/707C
W/AMENDMENT 1

TABLE IV. Manufacturers characterization conditions.

Manufactures CAGE	Inspection	MIL-STD-750		Sample plan
		Method	Conditions	
69210 (Applicable to devices with a date code of 16 June 1998 and older)	SEE <u>1/</u>	1080	See MIL-STD-750 method 1080.0 dated 20 November 2006. See figure 5	3 devices
	Electrical measurement s		I _{GSSF1} , I _{GSSR1} , and I _{DSS1} in accordance with table I, subgroup 2	
	SEE irradiation:		Fluence = 3E5 ±20 percent ions/cm ² Flux = 2E3 to 2E4 ions/cm ² /sec, temperature = 25 ±5°C Surface LET = 38 MeV-cm ² /mg ± 5% Range = 38 μm ±7.5%, Energy = 300 MeV ±7.5%	
	2N7500U5		In-situ bias conditions: V _{DS} = 130 V and V _{GS} = -20 V (typical 3.75 MeV/nucleon at Texas A & M Cyclotron)	
	2N7501U5		In-situ bias conditions: V _{DS} = 200 V and V _{GS} = -20 V (nominal 3.86 MeV/nucleon at Brookhaven National Lab Accelerator)	
	2N7502U5 & 2N7562U5		In-situ bias conditions: V _{DS} = 250 V and V _{GS} = -20 V (nominal 3.86 MeV/nucleon at Brookhaven National Lab Accelerator) Surface LET = 61 MeV-cm ² /mg ±5% Range = 31 μm ±10%, Energy = 330 MeV ±7.5%	
	2N7500U5		In-situ bias conditions: V _{DS} = 130 V and V _{GS} = -10 V V _{DS} = 100 V and V _{GS} = -15 V V _{DS} = 50 V and V _{GS} = -20 V (typical 2.70 MeV/nucleon at Texas A & M Cyclotron)	
	2N7501U5		In-situ bias conditions: V _{DS} = 200 V and V _{GS} = -10 V V _{DS} = 185 V and V _{GS} = -15 V V _{DS} = 120 V and V _{GS} = -20 V (nominal 2.92 MeV/nucleon at Brookhaven National Lab Accelerator)	
2N7502U5 & 2N7562U5		In-situ bias conditions: V _{DS} = 250 V and V _{GS} = -15 V V _{DS} = 240 V and V _{GS} = -20 V (nominal 2.92 MeV/nucleon at Brookhaven National Lab Accelerator)		

See footnotes at end of table.

MIL-PRF-19500/707C
W/AMENDMENT 1

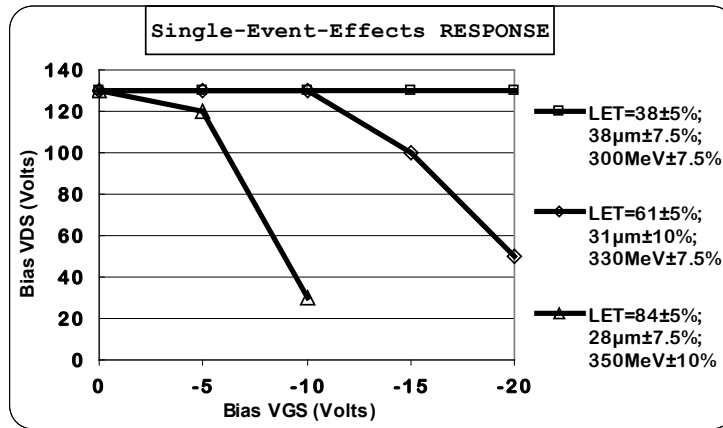
TABLE IV. Manufacturers characterization conditions - Continued.

Manufactures CAGE	Inspection	MIL-STD-750		Sample plan
		Method	Conditions	
	2N7500U5		Surface LET = 84 MeV-cm ² /mg ± 5% Range = 28 μm ±7.5%, Energy = 350 MeV ±10% In-situ bias conditions: V _{DS} = 130 V and V _{GS} = 0 V V _{DS} = 120 V and V _{GS} = -5 V V _{DS} = 30 V and V _{GS} = - 10 V (typical 1.89 MeV/nucleon at Texas A & M Cyclotron)	3 devices
	2N7501U5		In-situ bias conditions: V _{DS} = 200 V and V _{GS} = -5V V _{DS} = 150 V and V _{GS} = -10 V V _{DS} = 50 V and V _{GS} = -15 V V _{DS} = 25 V and V _{GS} = -20 V (nominal 1.98 MeV/nucleon at Brookhaven National Lab Accelerator)	
	2N7502U5 & 2N7562U5		In-situ bias conditions: V _{DS} = 250 V and V _{GS} = -5 V V _{DS} = 225 V and V _{GS} = -10 V V _{DS} = 175 V and V _{GS} = -15 V V _{DS} = 50 V and V _{GS} = -20 V (nominal 1.98 MeV/nucleon at Brookhaven National Lab Accelerator)	
	Electrical measurement s		I _{GSSF1} , I _{GSSR1} , and I _{DSS1} in accordance with table I , subgroup 2	
<div style="border: 1px solid black; padding: 5px; width: fit-content; margin: 0 auto;"> Upon qualification, all manufacturers should provide the verification test conditions to be added to this table. </div>				

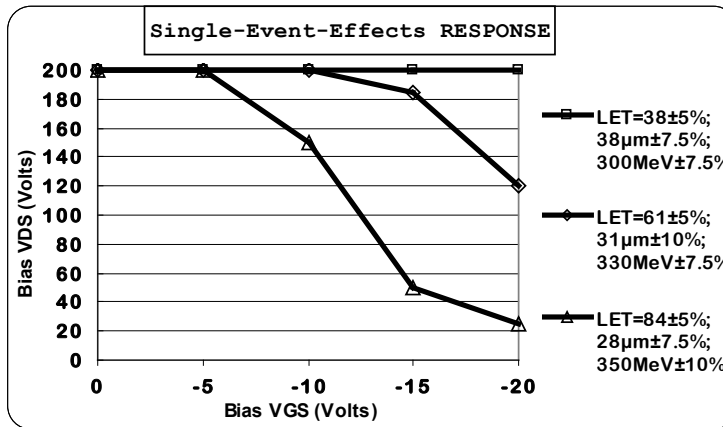
^{1/} I_{GSSF1}, I_{GSSR1}, and I_{DSS1} was examined before and following SEE irradiation to determine acceptability for each bias condition. Other test conditions in accordance with [table I](#), subgroup 2, may be performed at the manufacturer's option.

MIL-PRF-19500/707C
W/AMENDMENT 1

2N7500U5



2N7501U5



2N7502U5 and 2N7562U5

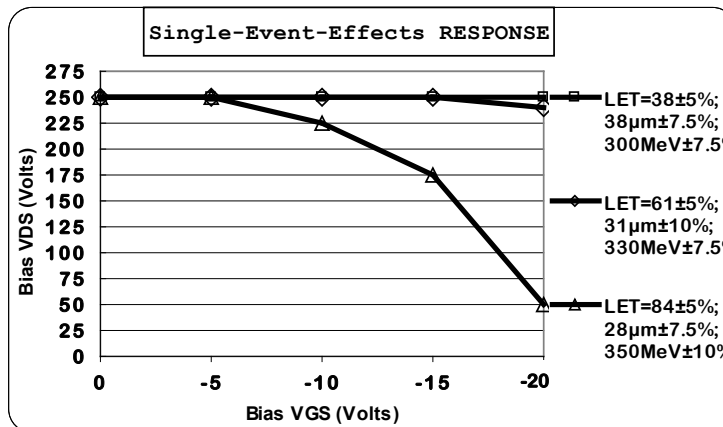


FIGURE 5. Typical SEE safe operating area graph.

MIL-PRF-19500/707C
W/AMENDMENT 1

6.9 Amendment notations. The margins of this specification are marked with asterisks to indicate modifications generated by this amendment. This was done as a convenience only and the Government assumes no liability whatsoever for any inaccuracies in these notations. Bidders and contractors are cautioned to evaluate the requirements of this document based on the entire content irrespective of the marginal notations and relationship to the last previous issue.

Custodians:
Army - CR
Navy - EC
Air Force - 85
NASA - NA
DLA - CC

Preparing activity:
DLA - CC

(Project 5961-2020-035)

Review activities:
Army - AV, MI
* Air Force - 19, 71

NOTE: The activities listed above were interested in this document as of the date of this document. Since organizations and responsibilities can change, you should verify the currency of the information above using the ASSIST Online database at <https://assist.dla.mil>.